



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

July 13, 2004

In re the Application of

Masaru MITSUI et al.

Group Art Unit: 1752

Application No.: 09/509,472

Examiner: Y. Thornton

Filed: April 21, 2000

Docket No.: 105875

For: PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING THE SAME  
AND METHOD OF FORMING MICROPATTERN

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 13, 2004, an extension of time for a period of three months is hereby requested. Attached hereto is our Check No. 156166 in the amount of \$950 in payment for:

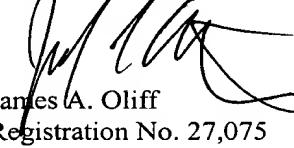
Extension fee for response within first month pursuant to §1.136(a) (\$110.00)

Extension fee for response within second month pursuant to §1.136(a) (\$420.00)

Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

  
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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
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